



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of:

Janis Virbulis et al.

Group Art Unit: 1722

Examiner: Matthew J. Song

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For: PROCESS AND APPARATUS FOR PRODUCING
A SILICON SINGLE CRYSTAL

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AMENDMENT UNDER 37 C.F.R. 1.121

Mail Stop Issue Fee
Commissioner for Patents
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Sir:

In response to the Notice to File Corrected Application Papers mailed May 17, 2010, please amend the above-identified application as follows:

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8 (FIRST CLASS MAIL)

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